FORM PTO-1449 (Modified) LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	ATTY. DOCKET NO. FIS9-2000-0149US1	SERIAL NO. Not Assigned
	APPLICANTS: David C. Ahlgren, Jack O. Chu, Basanth Jagannathan, Ryan W. Wuthrich	
	FILING DATE: Concurrently	GROUP: Not Assigned

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIALS		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPRO.)
		6,015,478	1/18/00	Satoh			
		6,010,914	1/4/00	Shishiguchi			
		5,951,757	9/14/99	Dubbelday			
		5,443,033	8/22/95	Nishizawa et al.			

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES	TRANSLATION NO

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

		L.L. Tedder et al.; "Real-Time Process and Procuct Diagnostics in Rapid Thermal Chemical Vapor Deposition Using In Situ Mass Spectrometric Sampling"; J. Vac. Sci. Technol. Jul/Aug 1995; pgs. 1924 - 1927

EXAMINER [signature] DATE CONSIDERED 3/20/02

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.